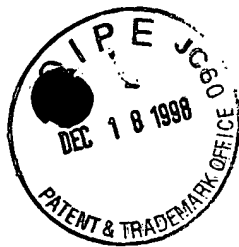


35.C11946



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE **RECEIVED**

JAN 22 1999

In re Application of: )  
AKIRA FUNAKOSHI, ET AL. )  
Appln. No.: 08/801,464 )  
Filed: February 18, 1997 )  
For: SUBSTRATE CUTTING METHOD )  
AND SUBSTRATE CUTTING )  
APPARATUS )

Examiner: C. Dexter  
Group Art Unit: 3724  
December 18, 1998

TECHNOLOGY CENTER 3700

The Assistant Commissioner for Patents  
Washington, D.C. 20231

REQUEST FOR OFFICIAL FILING RECEIPT

Sir:

To date, Applicants have not received an official Filing Receipt for the above-identified application. Accordingly, Applicants request that the U.S. Patent and Trademark Office promptly issue an official Filing Receipt for this application.

Favorable consideration is requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our new address listed below.

Respectfully submitted,



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